

<b>Notice of References Cited</b>	Application/Control No. 10/774,869		Applicant(s)/Patent Under Reexamination SHI ET AL.	
	Examiner JUNGHWA M. IM		Art Unit 2811	Page 1 of 1

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*	B	US-2002/0170901	11-2002	Lau, James C.	219/209
*	C	US-6,258,626	07-2001	Wang et al.	438/107
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	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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